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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

stitute for form 1449A/PTO

Complete if Known

Application Number 10/663,944

Filing Date September 16, 2003

First Named Inventor Warren M. Farnworth

Group Art Unit 2811 ≥ 82 3

Examiner Name Unknown (1/1/10 m M. Brewith)

(use as many sheets as necessary)

Sheet 1 of 2 Attorney Docket Number 5700US (02-1183.00/US)

Examiner Initials *	Cite No. ¹	Document Number	Publication Date	Name of Patentee or Applicant of	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number - Kind Code ² (if known)	MM-DD-YYYY	Cited Document		
2/8		US-6,251,488	06/26/01	Miller et al.	927/596	
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	FOREIGN PATENT DOCUMENTS							
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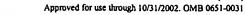
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Substitute for form 1449A/PTO Complete if Known **Application Number** 10/663,944 INFORMATION DISCLOSURE Filing Date September 16, 2003 **'STATEMENT BY APPLICANT** Warren M. Farnworth First Named Inventor 2811 2823 Group Art Unit Unknown William (use as many sheets as necessary) **Examiner Name** Attorney Docket Number

		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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Examiner Signature 9/2/200 mm m. Bremto	Date Considered	4AUG BY	•
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